

<b>Notice of References Cited</b>		Application/Control No. 10/511,914	Applicant(s)/Patent Under Reexamination LOILER ET AL.	
		Examiner Shin-Lin Chen	Art Unit 1632	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-7,462,592	12-2008	Zuckermann et al.	514/2
	B	US-			
	C	US-			
	D	US-			
	E	US-			
	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Miwa et al., 2000, Genseq Accession No. AAB23838, page 17.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a))  
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